Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination
10/026,172	FUJISAWA ET AL.
Evaminor	Art Unit

Pierre-Louis Desir

2681

	•				
SEARCHED					
Class	Subclass	Date	Examiner		
455	88	11/9/2006	PD		
340	5.61	11/9/2006	PD		
340	5.1	11/9/2006	PD		
360	10	11/9/2006	PD		
702	179	11/9/2006	PD		
368	108	11/9/2006	PD		
368	13	11/9/2006	PD		
		:			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
455	88	11/9/2006	PD	
360	10	11/9/2006	PD	
702	179	11/9/2006	PD	
368/1	3, 108	11/9/2006	PD	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST	11/9/2006	PD	
Steve D'Agosta	11/7/2006	PD	
Tommy Chin	11/8/2006	PD	